

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yoichi MORI et al.

Serial No. NEW

Filed November 17, 2000

Attn: Application Branch

Attorney Docket No. 2000-1578A

2hs
P.C.
4-10-01

METHOD AND APPARATUS FOR
TREATING A WASTE GAS CONTAINING
FLUORINE-CONTAINING COMPOUNDS

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

Prior to examination of the instant application, please enter and consider the following
amendments and remarks as follows:

In The Claims:

Kindly amend claim 7 as follows:

Claim 7. line 1, delete "or 6".

Kindly add the following new claim 8:

8. The apparatus according to claim 6, which has not only an air ejector capable
of adjusting the pressure in the apparatus through which the waste gas passes but also an FT-IR
analyzer for controlling the emission density of the treated gas.--